

# **CBD ANNOUNCEMENT**

**February 11, 1999**

## **ADDITIONAL VENDOR MEETINGS FOR ENVIRONMENTAL TECHNOLOGY VERIFICATION'S ADVANCED MONITORING SYSTEMS PILOT**

The National Exposure Research Laboratory (NERL), Office of Research and Development (ORD), U.S. Environmental Protection Agency (US EPA), Research Triangle Park (RTP), North Carolina 27711, and Battelle, Columbus, Ohio, are partners in an Environmental Technology Verification (ETV) pilot for Advanced Monitoring Systems (AMS). The goal of ETV is to verify the performance characteristics of commercially ready environmental technologies so potential purchasers and permittees are provided with an independent and credible assessment of the technology they are buying or permitting. The AMS pilot is focused on verifying air, water, and soil monitoring technologies.

The AMS pilot's next two vendor meetings will be held at Battelle's facilities in Columbus, Ohio, February 19 and 26, 1999, for vendors with ambient fine particulate air monitors and turbidimeters, respectively. The purpose of the vendor meetings is to give technology vendors the opportunity to suggest parameters for verification testing of their monitoring devices and to plan the test schedules. Vendors with ambient fine particulate monitors and turbidimeters are invited to join these meetings.

For more information about the AMS pilot and vendor opportunities for technology verification or to register for these vendor meetings, contact Helen Latham at Battelle, 505 King Avenue, Columbus, OH 43201, phone 614-424-4062, fax 614-424-5601, or email [lathamh@battelle.org](mailto:lathamh@battelle.org).